



Atty. Dkt. No. AMAT/5027/CPI/COPPER/PJS

1762

In re Application of:
Chen, et al

Group Art Unit: 1762

Examiner: Timothy H. Meeks

For: Method for Growing Thin
Films By Catalytic
Enhancement

MAIL STOP Non Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:


CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on
February 17, 2004 with the United States Postal Service as
First Class Mail in an envelope addressed to: Commissioner
for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

February 17, 2004

Date


Signature

RESPONSE TO NON-COMPLIANT AMENDMENT DATED FEBRUARY 4, 2004

In response to the Non-Compliant Amendment, dated February 4, 2004, having a shortened statutory period for response set to expire on March 4, 2004, regarding the Response to Office Action filed, December, 17, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/6198/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.